



AF/2814
Ifw

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Confirmation No.: 3293

Fumiaki MARUYAMA et al.

Group Art Unit: 2814

Application No.: 09/856,139

Examiner: A. Mai

Filed: May 29, 2001

Attorney Docket. No.: 107242-00017

For: WAFER AND EPITAXIAL WAFER, AND MANUFACTURING PROCESSES
THEREFOR

RESPONSE UNDER 37 CFR §1.116

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

September 7, 2004

Sir:

In reply to the outstanding Office Action dated June 4, 2004, the period for response expiring on September 4, 2004 (Saturday, with September 6, 2004, being a Federal Government Holiday), reconsideration of the above-identified patent application is respectfully requested in view of the following: